Overview (WS peroman 22.03.2023)

		Priority	Material Input	Settings	Process information	Material output	Measured quantities	Data processing	Derived quantities
Vapor Layer deposition	Sputter deposition								
Vapor Layer deposition	Thermal PVD/Evaporation								
Vapor Layer deposition	Pulsed laser deposition								
Vapor Layer deposition	Electron-beam-induced deposition								
Vapor Layer deposition	Molecular beam epitaxy								
Vapor Layer deposition	Metal organic chemical vapour deposition								
Vapor Layer deposition	Plasma assisted chemical vapour deposition								
Vapor Layer deposition	Atomic layer deposition								
Wet chemical deposition	Spin coating								
Wet chemical deposition	Slot die coating								
Wet chemical deposition	Drop casting								
Wet chemical deposition	Dip coating								
Wet chemical deposition	Doctor blading								
Wet chemical deposition	Aerosol printing								
Wet chemical deposition	Spray pyrolysis								
Wet chemical deposition	Spray coating								
Wet chemical deposition	Sol-gel deposition								
Wet chemical deposition	Dip coating								
Wet chemical deposition	Chemical bath deposition								
Wet chemical deposition	Chemical solution deposition								
Wet chemical deposition	Electrophoretic deposition								
Wet chemical deposition	Gravure printing								
Wet chemical deposition	Inkjet printing								
Wet chemical deposition	Offset printing								
Wet chemical deposition	Screen printing								
Material processing	Solvent cleaning								
Material processing	UV-Cleaning								
Material processing	Plasma cleaning								
Material processing	Anealing								
Material processing	Storing								
Material processing	Solution manufacturing								
Material processing	Gas quenching								
Material processing	Solvent quenching								
Solacell Characterisation									
Solacell Characterisation									
	Time-resolved photoluminescence								
Solacell Characterisation	1 11								
	Photoluminescence Measurement								
	Electroluminescence Measurement								
Solacell Characterisation	Transient optoelectronic measurement								